Spectrum Control Software

K9

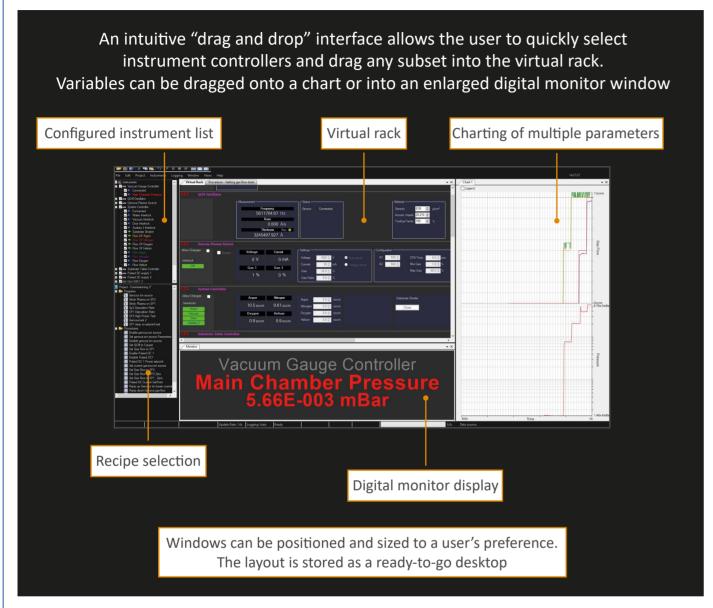
A powerful and intuitive package designed by experienced vacuum deposition specialists

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Software

Overview_



Configure virtual rack to suit your process. Easy to add and remove instruments. Real time charting. Interlock monitoring. Recipe control. Data logging.



Create and store

Software_

The Detail.

Virtual electronics rack

Display customisation

The virtual rack can be configured to display the desired functions for any task. Use the "drag and drop" interface to create, edit and organise the information within the virtual rack tab.

Comprehensive instrument interface

The interface supports both the newest instruments and existing tools. The modular configuration allows new instruments and system components to be seamlessly added to expand system functionality as your deposition requirements evolve.

Variable refresh rate

The instrument communication polling rate can be selected from several options and can be as frequent as every 0.5s.

Remote and local mode of operation of all instruments

Remote mode disables the front panel controls on the physical electronics rack allowing control through the software only. In local mode software control is disabled, however, changes made to parameters from the front panel of the rack are still monitored and can be logged if desired.

Graphical charting

Real-time display

The charting module provides a real-time display of numeric readings and settings for any chosen system parameter. The charts can be set to auto scale, or the range can be set by the user.

Graphing options

Each parameter is plotted on a separate but synchronised chart. The data will be displayed in different colours as wells as lines, points, or crosses. There are smoothing options available to give a clearer picture from noisy data.

Easy chart manipulation

Parameters of interest are simply dragged from the instrument list and dropped into the chart tab. There is no limit on the number of parameters that can be concurrently plotted other than the amount of information that can sensibly be displayed. Parameter charts no longer required are easily removed by a simple right click.

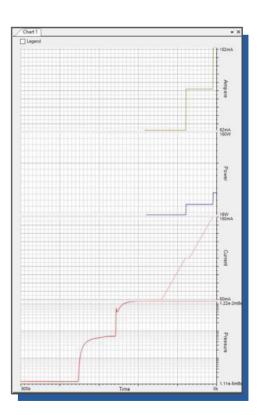
Image export

Each displayed plot can be instantly saved as a bitmap.

Variable time display

The time range may be altered to display the timeline for up to 1000 seconds.

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Software.

Parameter logging

Easy logging

Store all process and system parameters in a single file.

Popular file format

The text file is TAB delimited and can be read and amended by most spreadsheet editing programs for rapid, detailed inspection of any process parameter.

Instrument settings

All instrument parameters are logged by default – no possibility of forgetting to log a critical parameter when running a process if auto logging is enabled!

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Recipe process control

Full control

On a fully automated deposition system, procedures or programs can control any necessary setting on any system component.

Easy operation

Once written - recipes can be controlled through "Run", "Pause" and "Stop" buttons for ease of use.

Program management

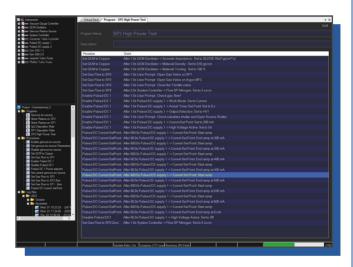
Recipes can be edited, saved, and reloaded from disk. Users can set up their own project directory where relevant recipes are stored.

Simple recipe editor

Recipes are defined using procedures (effectively a sub-routine) for basic tasks and programs for longer more complex processes. Simply "drag and drop" the parameter of interest into the sub-routine sequence, specify an action from a drop-down menu and set a value. Writing a program is just as simple - drag and drop the desired sub-routines into the program sequence. A repeat function allows sub-routines to be run as many times as necessary within a loop.

Recipe status

Prior to a program being run, the software will automatically check that all events are properly defined. During the run, the event that is being

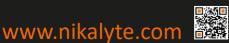


processed will be highlighted and a progress bar and timer will display the program progression to the operator.

Automated pump down and venting of the system Vent and pump down recipes ensure a consistent

approach to these critical operations, minimising the risk of operator error causing unnecessary wear or damage to expensive components.

For further information please contact: sales@nikalyte.com



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